

PTO-1449 Information Disclosure Citation in an Application	Application No.	Applicant(s) Eoff, et al.	
	Docket Number HES 2001-IP-005267U1P2	Group Art Unit Unassigned	Filing Date 3/23/2004

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
	1	2,863,832	12/09/58	PERRINE	507	267	05/14/54
	2	2,910,436	10/27/59	ALHAMBRA, ET AL.	166	307	10/02/53
	3	3,215,199	11/02/65	DILGREN	166	250.01	02/21/63
	4	3,297,090	01/10/67	DILGREN	166	300	04/24/64
	5	3,441,085	04/29/69	GIDLEY	166	307	09/07/67
	6	4,532,052	07/30/85	WEAVER, ET AL.	252	8.55 R	08/25/82
	7	5,944,106	08/31/99	DALRYMPLE, ET AL.	166	281	08/06/97
	8	5,972,848	10/26/99	AUDIBERT, ET AL.	507	119	10/15/96
	9	6,070,664	06/06/00	DALRYMPLE, ET AL.	166	281	02/12/98
	10	6,476,169	11/05/02	EOFF, ET AL.	523	307.2	09/28/00
	11	6,497,283	12/24/02	EOFF, ET AL.	166	293	11/19/01
	12	6,569,983	05/27/03	TREYBIG, ET AL.	528	102	12/20/01
	13	10/236,722	03/11/04	EOFF, ET AL.	166	293	09/06/02
	14	10/375,787	03/02/04	EOFF, ET AL.	507	100	02/27/03
	15	10/763,800	07/28/05	EOFF, ET AL.	507	200	01/24/04
	16	6,476,283	11/05/02	DEVORE, ET AL.	585	250	06/29/00

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
	17	WO 02/097236 A1	12/05/02	PCT	E21B	43/02	X	

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	

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PTO-1449	Application No.	Applicant(s) Eoff, <i>et al.</i>	
	Information Disclosure Citation in an Application	Docket Number 2001-IP-005267U1P2	Group Art Unit Filing Date 3/23/04

U.S. PATENT DOCUMENTS

		DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
	17	3,307,630	03/07/67	Dilgren, et al	166	38	06/12/64
	18	3,251,415	05/17/66	Bombardier, et al	166	42	04/01/65
	19	6,364,016	04/02/02	Dalrymple, et al	166	270	10/26/00
	20	5,271,466	12/21/93	Harms	166	300	10/30/92
	21	5,735,349	04/07/98	Dawson, et al	166	295	08/16/96
	22	6,228,812	05/08/01	Dawson, et al	507	221	04/05/99
	23	6,283,210	09/04/01	Soliman, et al	166	270	09/01/99

FOREIGN PATENT DOCUMENTS


		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					
	24	INIKORI, SOLOMON OVUEFERAYE, "Numerical Study of Water Coning Control with Downhole Water Sink (DWS) Well Completions in Vertical and Horizontal Wells," A Dissertation, August 2002, title page, contents, abstract and pp. 17-18, The Department of Petroleum Engineering					
	25	HALLIBURTON, 2001 Press Release, "First Halliburton H2Zero™ Conformance Solution Job Performed for a Producing Well in Egypt," www.halliburton.com/news/archives/2001esgnws_111901.jsp , November 19, 2001, 2 pp.					
	26	HALLIBURTON, 2001 Press Release, "Halliburton Performs First H2Zero™ Conformance Solution Job in North America," www.halliburton.com/news/archives/2001esgnws_082201.jsp , August 22, 2001, 2 pp.					
	27	HALLIBURTON, 2001 Press Release, "Halliburton Technology Uses Revolutionary Polymer system to Control Unwanted Water Production," www.halliburton.com/news/archives/2001lesgnws_053101.jsp , May 31, 2001 2 pp.					
	28	BJ SERVICES COMPANY, Aquacon, 08/01/01, 2 pp.					
	29	BJ SERVICES COMPANY, Aquatrol 1, 12/14/00, 2 pp.					
	30	EOFF, LARRY ET AL., "Structure and Process Optimization for the Use of a Polymeric Relative-Permeability Modifier in Conformance Control," SPE eLibrary paper no. 64985, 2001 Copyright, 2 pp.					
	31	BOTERMANS, C. WOUTER ET AL. "Relative Permeability Modifiers: Myth or Reality?" SPE eLibrary paper no. 68973, 2001 copyright, 2 pp.					
	32	BJ SERVICES COMPANY, Aquacon, 08/01/01, 2 pp.					

EXAMINER 	DATE CONSIDERED 6/22/2004
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Information Disclosure Citation in an Application

Applicant(s): **EOFF, ET AL.**

Group Art Unit
Not Yet
Assigned

Filing Date
March 23, 2004

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								TRANSLATION	
DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO			

NON-PATENT DOCUMENTS

NON-PATENT DOCUMENTS			DATE
DOCUMENT (Including Author, Title, Source, and Pertinent Pages)			

DATE CONSIDERED

6/22/2008

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PTO-1449 Information Disclosure Citation in an Application	Application No. 10/806,894	Applicant(s) Eoff, et al.	
	Docket Number HES 2001-IP-005267U1P2	Group Art Unit Unassigned	Filing Date 03/23/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
1	5,669,456	09/23/97	AUDIBERT, ET AL.	175	72	07/01/96
2	6,710,107	10/23/04	AUDIBERT, ET AL.	524	5	02/09/01
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FOREIGN PATENT DOCUMENTS

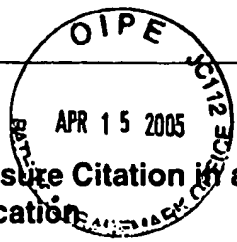
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	<i>[Signature]</i>	6/22/2006

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	Docket Number 2001-IP-005267U1P2	Group Art Unit	Filing Date 03/23/2004



U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
	3,382,924	05/14/68	Veley, et al	166	42	09/06/66
	3,434,971	03/25/69	Atkins	252	8.55	08/25/65
	3,451,818	06/24/69	Wareham	96	78	04/19/66
	3,910,862	10/07/75	Barabas, et al	260	79.3MU	08/27/73
	4,129,183	12/12/78	Kalfoglou	166	300	06/30/77
	4,158,521	06/19/79	Anderson, et al	405	264	06/26/78
	4,299,710	11/10/81	Dupre, et al	252	8.5A	05/30/75
	4,366,071	12/28/82	McLaughlin, et al	252	8.55R	02/04/80
	4,366,072	12/28/82	McLaughlin, et al	252	8.55R	02/04/80
	4,366,073	12/28/82	McLaughlin, et al	252	8.55R	02/04/80
	4,366,074	12/28/82	McLaughlin, et al	252	8.55R	02/04/80
	4,374,739	02/22/83	McLaughlin, et al	252	8.55R	02/04/80
	4,393,939	07/19/83	Smith, et al	166	293	04/20/81
	4,395,340	07/26/83	McLaughlin	252	8.55D	07/14/81
	4,401,789	08/30/83	Gideon	524	827	07/14/81
	4,439,334	03/27/84	Borchardt	252	8.55D	07/14/81
	4,440,649	04/03/84	Loftin, et al	252	8.5C	01/28/82
	4,447,342	05/08/84	Borchardt, et al	252	8.55D	04/19/82
	4,460,627	07/17/84	Weaver, et al	427	212	08/25/82
	4,462,718	07/31/84	McLaughlin, et al	405	264	05/04/78
	4,536,297	08/20/85	Loftin, et al	252	8.5C	01/19/84
	4,536,305	08/20/85	Borchardt, et al	252	8.55R	09/21/84
	4,554,081	11/19/85	Borchardt, et al	252	8.5A	05/21/84
	4,563,292	01/07/86	Borchardt	252	8.55R	08/02/84
	4,604,216	08/05/86	Irvin, et al	252	8.510	06/11/84

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <i>6/29/2006</i>
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	Docket Number 2001-IP-005267U1P2	Group Art Unit	Filing Date 03/23/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>DF</i>	4,627,926	12/09/86	Peiffer, et al	252	8.55R	09/19/84
<i>f</i>	4,693,639	09/15/87	Hollenbeak, et al	405	263	06/25/86
	4,699,722	10/13/87	Dymond, et al	252	8.551	05/23/85
	4,730,028	03/08/88	Bock, et al	526	225	03/28/86
	4,828,726	05/09/89	Himes, et al	252	8.553	09/11/87
	4,959,432	09/25/90	Fan, et al	526	287	07/18/88
	5,071,934	12/10/91	Peiffer	526	307	07/03/89
	5,097,904	03/24/92	Himes	166	294	02/28/91
	5,146,986	09/15/92	Dalrymple	166	294	12/11/91
	5,160,642	11/03/92	Schild, et al	252	8.551	05/25/90
	5,197,544	03/30/93	Himes	166	294	12/18/91
	5,208,216	05/04/93	Williamson, et al	507	120	06/30/92
	5,244,042	09/14/93	Dovan, et al	166	270	02/26/92
	5,342,530	08/30/94	Aften, et al	252	8.551	05/04/92
	5,379,841	01/10/95	Pusch, et al	166	295	04/12/93
	5,607,902	03/04/97	Smith, et al	507	120	03/04/96
	5,887,653	03/30/99	Bishop, et al	166	281	08/15/97
	5,972,848 (English Equiv. of WO 93/15164)	10/26/99	Audibert, et al	507	119	10/15/96
	5,979,557	11/09/99	Card, et al	166	300	05/29/97
	6,187,839 B1	02/13/01	Eoff, et al	523	130	03/03/99
	6,237,687 B1	05/29/01	Barbee, Jr., et al	166	278	06/09/99
	6,253,851 B1	07/03/01	Schroeder, Jr., et al	166	278	09/20/99
	6,277,900 B1	08/21/01	Oswald, et al	523	130	11/19/98
<i>DF</i>	6,380,137 B1 (English Equiv. of EP 1 033 378 A1)	04/30/02	Heier, et al	507	121	03/02/00

EXAMINER: <i>[Signature]</i>	DATE CONSIDERED: <i>6/22/06</i>
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	Docket Number 2001-IP-005267U1P2	Group Art Unit	Filing Date 03/23/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
✓	6,476,283 B1	11/05/02	Devore, et al <i>Justified</i>	585	250	08/29/00
✓	6,497,283 B1	12/24/02	Eoff, et al <i>Justified</i>	166	293	11/19/01
✓	6,516,885 B1	02/11/03	Munday	166	295	01/26/99
✓	6,569,983 B1	05/27/03	Treybig, et al	528	102	12/20/01
✓	6,609,578 B2	08/26/03	Patel, et al	175	64	06/18/01
✓	6,710,107 B2	03/23/04	Audibert, et al	524	5	02/09/01
✓	US 2003/0019627 A1	01/30/03	Qu, et al	166	281	01/17/02
✓	US 2004/0102331 A1	05/27/04	Chan, et al	507	100	11/22/02
✓	US 2004/0045712A1 (US Pat. App. Ser. No. 10/236,722)	03/11/04	Eoff, et al (Ref. No. 2000-IP-002244U1)	166	293	09/06/02
✓	US 2004/0171495A1 (US Pat. App. Ser. No. 10/375,787)	09/02/04	Zamora, et al (Ref. No. 2002-IP-007056U1)	507	100	02/27/03
✓	US 2004/0229756A1 (US Pat. App. Ser. No. 10/440,337)	11/18/04	Eoff, et al (Ref. No. 2001-IP-005267U1)	507	219	05/16/03
✓	US 2004/0229757A1 (US Pat. App. Ser. No. 10/760,443)	11/18/04	Eoff, et al (Ref. No. 2001-IP-005267U1P1)	507	219	01/20/04
✓	US 2005/0000694A1 (US Pat. App. Ser. No. 10/612,271)	01/06/05	Dalrymple, et al (Ref. No. 2002-IP-007945U1)	166	307	07/02/03
✓	US Pat. App. Ser. No. 10/763,800	-	Eoff, et al (Ref. No. 2002-IP-009464U1)	-	-	01/24/04
✓	US Pat. App. Ser. No. 10/780,995	-	Eoff, et al (Ref. No. 2002-IP-007848U1)	-	-	02/18/04

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DATE CONSIDERED *6/22/06*

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		Docket Number 2001-IP-005267U1P2		Group Art Unit		Filing Date 03/23/2004	

U.S. PATENT DOCUMENTS							
		DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS								
		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							Yes	No
DSF		DT 2 250 552	04/18/74	Germany (Tropkleben)	39b4	19/00	X	
DSF		EP 0 383 337 A2	08/22/90	Europe	E21B	33/138	X	
DSF		EP 0 896 122 A2	02/10/99	Europe	E21B	33/138	X	
		EP 1 033 378 A1						
		(See Equivalent, US 6,380,137 B1)	<i>Equivalent cited elsewhere</i>					X
DSF		EP 1 193 365 A1	04/03/02	Europe	E21B	33/138	X	
DSF		EP 1 312 753 A1	05/21/03	Europe	E21B	33/138	X	
DSF		GB 2 221 940 A	02/21/90	UK	C09K	7/02	X	
		WO 93/15164						
		(See Equivalent, US 5,972,848)	<i>Equivalent cited elsewhere</i>					X
DSF		WO 99/49183	09/30/99	PCT	E21B	43/02	X	
DSF		WO 99/50530	10/07/99	PCT	E21B	43/02	X	

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	Docket Number 2001-IP-005267U1P2	Group Art Unit	Filing Date 03/23/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>JSF</i>	4,158,726	06/19/79	Kamada, et al	526	200	12/27/77
<i>JSF</i>	4,536,303	08/20/85	Borchardt	252	8.55R	08/02/84
<i>JSF</i>	4,671,883	06/09/87	Connell	252	8.515	07/12/85
<i>JSF</i>	6,124,245	09/26/00	Patel	507	120	10/07/98
<i>JSF</i>	6,359,047 B1	03/19/02	Thieu, et al	524	376	03/20/01
<i>JSF</i>	6,787,506 B2	09/07/04	Blair, et al	507	222	04/03/02
<i>JSF</i>	US 2003/0191030A1	10/09/03	Blair, et al	507	225	04/03/02
		<i>Duplicate of 6,787,506</i>				

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
<i>JSF</i>	Botermans, C. Wouter, et al, <i>Relative Permeability Modifiers: Myth or Reality?</i> , SPE No. 68973, 2001, Society of Petroleum Engineers, Inc., presented at SPE European Formation Damage Conference, The Hague, The Netherlands, May 21-22, pp. 1-13 (previously listed as website address, SPE eLibrary)	
<i>JSF</i>	Eoff, Larry, et al, <i>Structure and Process Optimization for the Use of a Polymeric Relative-Permeability Modifier in Conformance Control</i> , SPE No. 64985, 2001, Society of Petroleum Engineers, Inc., presented at SPE International Symposium on Oilfield Chemistry, Houston, TX, February 13-16, pp. 1-14 (previously listed as website address, SPE eLibrary)	

EXAMINER <i>John P. Jagers</i>	DATE CONSIDERED <i>6/23/2006</i>
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PTO-1449

Information Disclosure Citation in an Application

Application No.
10/806,894

Applicant(s)
Larry S. Eoff, et al.

Docket Number
2001-IP-005267U1P2

Group Art Unit
3672

Filing Date
03/23/2004

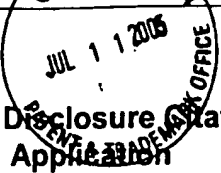
U.S. PATENT DOCUMENTS

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	US 2004/0220058A1 (US Pat. App. Ser. No. 10/862,132)	11/04/04	Eoff, et al (Ref. No. 2000-IP-002244U1P1)	507	200	06/04/04
	US Pat. App. Ser. No. 10/806,894		Eoff, et al (Ref. No. 2001-IP-005267U1P2)			03/23/04
	US Pat. App. Ser. No. 10/825,001		Eoff, et al (Ref. No. 2002-IP-007056U2)	-	-	04/15/04
	US Pat. App. Ser. No. 10/872,997	-	Eoff, et al (Ref. No. 2003-IP-011298U3)	-	-	06/21/04
	US Pat. App. Ser. No. 10/881,198	-	Dalrymple, et al (Ref. No. 2003-IP-012775U1)	-	-	06/29/04
	US Pat. App. Ser. No. 10/893,210	-	Eoff, et al (Ref. No. 2001-IP-005267P6)	-	-	07/16/04
	US Pat. App. Ser. No. 11/102,062	-	Sierra, et al (Ref. No. 2003-IP-012775U1P1)	-	-	04/08/05

EXAMINER *[Signature]*

DATE CONSIDERED 6/22/2004

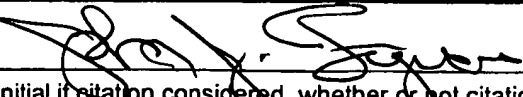
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PTO-1449 Information Disclosure Statement in an Application	Application No. 10/806,894	Applicant(s) Larry S. Eoff, et al.	
	Docket Number 2001-IP-005267U1P2	Group Art Unit 3672	Filing Date 03/23/2004

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
585	WO 04/101706 A1	11/25/2004	PCT	E21B	43/25	X	

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PTO-1449

Information Disclosure Citation
in an Application

Application No.
10/806,894

Applicant(s):
EOFF, ET AL.

Docket Number
2001-IP-005267U1P2

Group Art Unit
3672

Filing Date
03/23/2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
1.	4,142,595	03/06/79	Anderson, et al.	175	72	02/13/78
2.	5,646,093	07/08/97	Dino	507	209	08/13/96
3.	5,728,653	03/17/98	Audibert, et al.	507	222	06/05/95
4.	6,020,289	02/01/00	Dymond	507	120	05/22/96
5.	6,803,348 B2	10/12/04	Jones, et al.	507	221	03/22/99

FOREIGN PATENT DOCUMENTS

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						YES	NO
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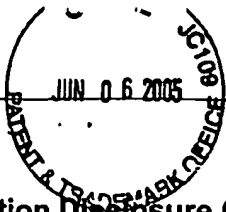
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EXAMINER

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PTO-1449 Information Disclosure Citation in an Application	Application No. 10/806,894	Applicant(s) Larry S. Eoff, et al	
	Docket Number 2001-IP-005267U1P2	Group Art Unit	Filing Date 03/23/2004

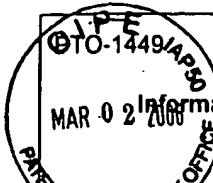
U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/ PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
<i>JSF</i>	3,744,566	07/10/73	Szabo et al.	166	275	03/16/72
<i>JSF</i>	5,382,371	01/17/95	Stahl et al.	507	221	11/06/92
	5,979,557	11/09/99	Card et al.	166	300	05/29/97
<i>Duplicate - cited elsewhere</i>						

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	

EXAMINER <i>[Signature]</i>	DATE CONSIDERED <i>6/22/2006</i>
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

	Application No. 10/806,894	Applicant(s): LARRY S. EOFF ET AL.	
	Docket Number 2001-IP-005267U1P2	Group Art Unit 3672	Filing Date 03/23/04

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	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
1.	5,597,783	01/28/97	Audibert, et al.	507	120	05/04/95
2.	5,637,556	06/10/97	Argillier, et al.	507	120	05/04/95
3.	5,720,347	02/24/98	Audibert, et al.	166	294	01/11/96
4.	4,814,096	03/21/89	Evani	252	8.554	08/01/83
5.	US 2005/0230110 US Pat. App. Ser. No. 11/183,028	-	Nguyen, et al.	-	-	07/15/05

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
	WO 2004/094781	11/4/04	PCT	E21 B	43/26	X	
	WO 2003/056130	07/10/03	PCT	E21B	43/26	X	
	WO 2000/78890	12/28/00	PCT	C09K	7/02	X	

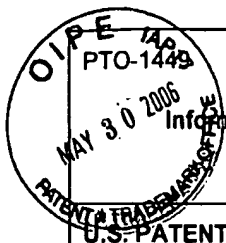
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	XU, ET AL., MODELING OF LASER SPALLATION DRILLING OF ROCKS FOR GAS-AND OILWELL DRILLING, SPE 95746, 2005	
	GAHAN, ET AL., EFFECT OF DOWNHOLE PRESSURE CONDITIONS ON HIGH-POWER LASER PERFORATION, SPE 97093, 2005	
	GAHAN, ET AL., ANALYSIS OF EFFICIENT HIGH-POWER FIBER LASERS OF WELL PERFORATION, SPE 90661, 2004	
	PARKER, ET AL., WELL PERFORATION USING HIGH-POWER LASERS, SPE 84418, 2003	
	PARKER, ET AL., LASER DRILLING: EFFECTS OF BEAM APPLICATION METHODS ON IMPROVING ROCK REMOVAL, SPE 84353, 2003	
	BAI, ET AL., IMPROVED DETERMINATION OF STREE-DEPENDENT PERMEABILITY FOR ANISOTROPIC FORMATIONS, SPE 78188, 2002	
	PROETT, ET AL., ADVANCED PERMEABILITY AND ANISOTROPY MEASUREMENTS WHILE TESTING AND SAMPLING IN REAL-TIME USING A DUAL PROBE FORMATION TESTER, SPE 62919, 2000	
	PROETT, ET AL., ADVANCED DUAL PROBE FORMATION TESTER WITH TRANSIENT, HARMONIC, AND PULSED TIME-DELAY TESTING METHODS DETERMINES PERMEABILITY, SKIN AND ANISOTROPY, SPE 64650, 2000	

EXAMINER

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Information Disclosure Citation
in an Application

Application No.
10/806,894

Applicant(s):
LARRY S. EOFF ET AL.

Docket Number
2001-IP-05267U1P2

Group Art Unit
3672

Filing Date
03/23/2004

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	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
JSF	1. 4,152,274	05/01/79	Phillips, et al.	876	296	02/09/78
JSF	2. 4,552,670	11/12/85	Lipowski, et al.	704	553	02/22/85
JSF	3. 6,627,719	09/30/03	Whipple, et al.	774	325	01/31/01
JSF	4. 6,855,672	02/15/05	Poelker	507	225	11/07/01
	5. US 2003/0104948 US Pat. App. Ser. No. 10/045,221	06/05/03	Poelker, et al.	507	100	11/07/01
JSF	6. US 2004/0171495 US Pat. App. Ser. No. (10/375,787)	09/02/04	Zamora, et al.	507	100	02/27/03

Disclosed as 6,855,672

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

NON-PATENT DOCUMENTS

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6/22/2004

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